

The proposed device relies on TE to TM, or vice versa, polarization conversion of optical modes owing to the AO interaction. The SAW induces a periodic stress along the direction of propagation of the optical wave. Through the photoelastic effect, a corresponding periodic rotation of the crystal refractive index ellipsoid occurs, making possible the energy transfer between orthogonally polarized optical modes. The conversion is efficient at the phase-matching condition $\Delta = |\beta_M - \beta_E| - K = 0$, with $K = 2\pi/\Lambda$ the acoustic wavenumber, Λ the acoustic wavelength, and β_E (β_M) being the propagation constant of the TE (TM) mode. In correspondence to phase matching, we obtain

$$f_a = \frac{V_{\text{SAW}}}{\lambda_0} |N_E - N_M|, \quad (1)$$

where f_a is the phase-matching acoustic frequency, V_{SAW} is the velocity of the SAW, λ_0 is the optical wavelength, and $N_{E(M)}$ is the effective index of the TE (TM) mode. Given the SAW frequency f_a , only optical waves satisfying the condition in Eq. (1) will experience the maximum polarization conversion. For optical wavelengths far from λ_0 the phase-matching condition is no longer satisfied and the conversion efficiency rapidly decreases.

The power conversion efficiency η between TE and TM modes is defined as the ratio of the converted power at $x=L_i$ (L_i is the interaction length) and the input power at $x=0$ [11],

$$\eta = \frac{P_M(x=L_i)}{P_E(x=0)} = \frac{\kappa^2}{\kappa^2 + \Delta^2} \sin^2(L_i \sqrt{\kappa^2 + \Delta^2}),$$

$$\eta(\Delta=0) = \sin^2(\kappa L_i), \quad (2)$$

where κ denotes the coupling coefficient. As shown in Eq. (2), κ will determine the conversion efficiency of the structure along with the phase mismatch Δ . Moreover, the 3 dB bandwidth of the AO filter is inversely proportional to the interaction length L_i , namely,

$$\Delta\lambda \approx 0.86 \frac{\lambda_0^2}{L_i |N_E - N_M|}. \quad (3)$$

As illustrated in Fig. 1, the structure, which is realized on 500- μm -thick z -cut LiNbO_3 , consists of two main parts, namely, the optical waveguide and the S-ASL transducer. The optical waveguide was fabricated through indiffusion of Ti on the $-z$ face at $T = 1060^\circ\text{C}$ for 7 h. The width and thickness of the Ti film before diffusion were chosen to get a final waveguide width of $W = 6 \mu\text{m}$ to obtain single-mode propagation at around 1450 nm. The ASL structure was fabricated by an electric-field domain inversion technique [12]. The period of the superlattice (acoustic wavelength) is $\Lambda = 20 \mu\text{m}$, which corresponds to the Rayleigh type SAW excitation at a frequency of $f_a = V_{\text{SAW}}/\Lambda = 190 \text{ MHz}$ with $V_{\text{SAW}} = 3795 \text{ m/s}$ in ZX- LiNbO_3 . The final ASL structure comprises 500

periods reaching a total length of $L_a = 10 \text{ mm}$. A pair of 200-nm-thick coplanar aluminum electrodes, with a gap of $100 \mu\text{m}$ and a width of $W = 100 \mu\text{m}$, was fabricated by sputtering deposition and subsequent wet etching. The electrodes were aligned parallel to the optical waveguide so that the waveguide remained in the center. The total length of the electrode is taken to be $L_e = L_a = 10 \text{ mm}$. To increase the optical coupling efficiency to the input and output fibers and to avoid backreflection effects of the SAW, the sample's edges were polished at $\theta = 8^\circ$.

The experimental characterization setup is shown in Fig. 2. A supercontinuum laser source was used to generate a broad spectrum in the wavelength region of interest and a pigtailed station was used to couple light into and out of the waveguide through a pair of single mode fiber blocks in a butt-coupling configuration. The polarizer (P) and the analyzer (A) were set to be orthogonal to each other and placed before and after the sample. An optical spectrum analyzer (OSA) was used to monitor the optical output, while a network analyzer was used to measure the electroacoustic response. For the acoustic generation, an amplified rf signal generator was employed.

We initially characterized the S-ASL by measuring the scattering parameter S_{11} . As shown in the inset of Fig. 3 a strong depth around the resonance frequency of $f_a = 189.94 \text{ MHz}$ is obtained, thus demonstrating the SAW generation as expected. The corresponding impedance match of the device around that frequency is measured to be about 65Ω . After the electroacoustic characterization, we measured the AO response. By keeping P_{rf} constant at 500 mW, the rf f_{rf} was swept around the resonance frequency f_a and the optical output was measured around the phase-matching wavelength of $\lambda = 1456 \text{ nm}$ (Fig. 3). The values reported in Fig. 3 are normalized to the peak value at the phase matching ($\Delta = 0$). At an rf power (P_{rf}) of 500 mW and a frequency (f_{rf}) equal to f_a (189.94 MHz), the output optical intensity is measured as a function of the wavelength (Fig. 4). The 3 dB optical bandwidth (FWHM) $\Delta\lambda$ is 2.51 nm. From Fig. 3 the acoustic FWHM (Δf) is estimated to be about 310 kHz, which is in good agreement with the theoretical prediction ($\Delta f_{\text{th}} = f_a (\Delta\lambda/\lambda) = 327 \text{ kHz}$). From these data and using Eq. (3) we can estimate an interaction length of $L_i = 9 \text{ mm}$, which is very close to the physical electrode length.

The polarization conversion efficiency (η)—i.e., the ratio between converted and transmitted power in the absence of an rf signal—as a function of the rf

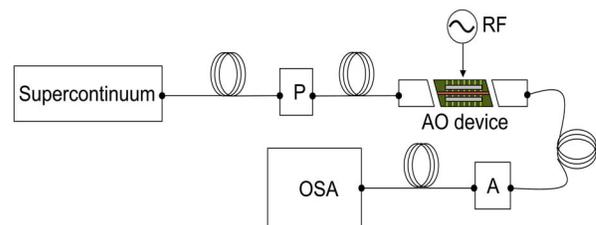


Fig. 2. (Color online) Experimental characterization setup. P and A, polarizer and analyzer, respectively; OSA, optical spectrum analyzer.

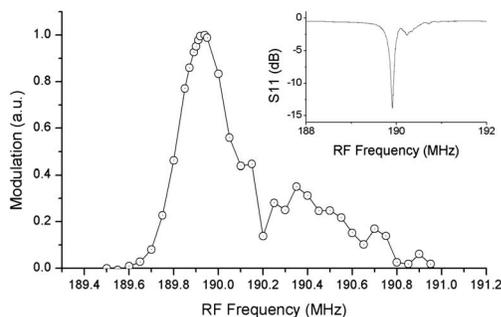


Fig. 3. AO modulation as a function of rf (f_{rf}) at phase matching (around $\lambda=1456$ nm) for a P_{rf} of 500 mW. In the inset the electroacoustic response of the S-ASL (S11 parameter) as a function of f_{rf} is shown.

power is shown in Fig. 5 for values of P_{rf} ranging from 100 to 1600 mW. One can estimate that the 90% conversion is reached for $P_{rf}=1$ W. This shows that the proposed integrated AO device is significantly more efficient than its bulk counterpart previously reported where, for the same input power, only around 40% mode conversion was achieved [9]. The shift in resonance frequency reported in Fig. 5 for different P_{rf} is mainly due to the thermal drift associated with the rf dissipation, as was already been reported elsewhere, including in [9].

In conclusion, we have presented a monolithic and integrated SAW-based AO polarization converter using a S-ASL transducer. The SAW was excited through the ASL via coplanar electrodes, allowing a metal-free AO waveguide interaction. The TE-TM polarization conversion is achieved through collinear interaction between the generated SAW and the optical waveguide mode. The achieved efficiency and interaction length indicate a strong confinement of the SAW in between the electrodes gap. Further work is required to improve the efficiency of the device in terms of the driving rf power. This would also significantly reduce the heat dissipation and consequently minimize the shift in resonance frequency. The

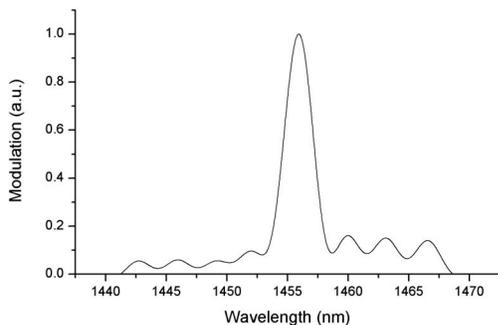


Fig. 4. Optical modulation as a function of wavelength λ for an rf input power of 500 mW and a rf of 189.94 MHz.

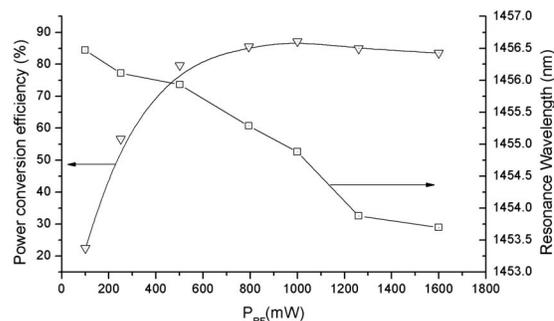


Fig. 5. Power conversion efficiency and resonance wavelength versus rf power.

implementation of the proposed concepts in *ad hoc* designed aperiodic (e.g., chirped) S-ASL can lead to the development of tunable filters, in particular for optical telecommunications, which typically require a tuning range larger than that achieved in this work with uniform periodic ASL.

D. Yulistira and D. Janner acknowledge the support of Generalitat de Catalunya and the Spanish Ministry through a studentship and the Juan De la Cierva fellowship programs, respectively. This work was partially supported by Plan Nacional TEC 2007-60185, Acciones Integradas Hispano-Francesa HF 2008-0033 and by the French Partenariat Hubert Curien (PHC) PICASSO 19220SG. We thank H. Herrmann and W. Sohler for their collaboration.

References

1. M. K. Smith, A. M. J. Koonen, H. Herrmann, and W. Sohler, in *Fiber Optic Communication* (Springer-Verlag, 2001), pp. 262–312.
2. S. K. Dubey, T. Anna, C. Shakher, and D. S. Mehta, *Appl. Phys. Lett.* **91**, 181106 (2007).
3. T. Xie, Z. Wang, and Y. Pan, *Appl. Opt.* **44**, 4272 (2005).
4. N. Gupta and R. Dahmani, in *Proceedings of the 19th Annual International Conference of the IEEE Engineering in Medicine and Biology Society (IEEE, 1997)*, Vol. 702, p. 702.
5. L. N. Binh and J. Livingstone, *IEEE J. Quantum Electron.* **16**, 964 (1980).
6. H. Herrmann, P. Muller-Reich, V. Reimann, R. Ricken, H. Seibert, and W. Sohler, *Electron. Lett.* **28**, 642 (1992).
7. Y.-Q. Lu, Y.-Y. Zhu, Y.-F. Chen, S.-N. Zhu, N.-B. Ming, and Y.-J. Feng, *Science* **284**, 1822 (1999).
8. Y. Zhu and N. Ming, *J. Appl. Phys.* **72**, 904 (1992).
9. H. Gnewuch, N. K. Zayer, C. N. Pannell, G. W. Ross, and P. G. R. Smith, *Opt. Lett.* **25**, 305 (2000).
10. D. Yulistira, S. Benchabane, D. Janner, and V. Pruneri, *Appl. Phys. Lett.* **95**, 052901 (2009).
11. Y. Ohmachi, *J. Appl. Phys.* **44**, 3928 (1973).
12. J. Amin, V. Pruneri, J. Webjörn, P. Russell, D. Hanna, and J. Wilkinson, *Opt. Commun.* **135**, 41 (1997).